

ABSTRACT**SYSTEM AND METHOD FOR SINTERING STRUCTURES ON A BASE**

5 The invention provides a system and a method for sintering one or more structures on
a base (10). The system comprises at least one sinter unit (50) that is configured to sinter
the structures on the base (10). The sinter unit (50) is further configured to position at
least one film layer (522) to be in proximity to the structures on the base (10), and apply
force and provide heat to the film layer (522) and the structures on the base (10) for the
10 structures to sinter. A corresponding method is further described.

(Fig. 1)

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